



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: **Masashi GOTO et al.**

Title: **DIELECTRIC FILM, ITS FORMATION METHOD,  
SEMICONDUCTOR DEVICE USING THE DIELECTRIC  
FILM AND ITS PRODUCTION METHOD**

Application No.: **10/726,870**

Filing Date: **2 December, 2003**

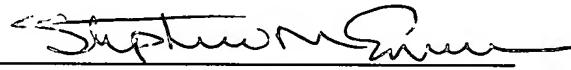
Examiner/Unit: **Dao H. Nguyen / 2818**

Attorney Docket No.: **2204-011-03**

**CERTIFICATE OF MAILING**

I hereby certify that this communication, and any document being attached hereto, is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail addressed to: MS RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450

on this 11<sup>th</sup> day of August 2006.



Stephen M. Evans

**RESPONSE TO FINAL OFFICE ACTION**

**TO COMMISSIONER FOR PATENTS**

This paper is filed in response to the Final Office Action dated 11 May 2006, coupled with issues identified in the Examiner interview with applicant's attorney on 21 July 2006. It is requested that the Examiner please amend and reconsider the application in view of this communication.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.